

*Image*

1203

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/087,510  
Applicants : SETHURAMAN JAYASHANKAR ET AL  
Filed : March 1, 2002  
Title : SINGLE LAYER RESIST LIFT-OFF  
PROCESS AND APPARATUS FOR  
SUBMICRON STRUCTURES

Group Art Unit : 1765  
Examiner : Shamim Ahmed  
Docket No. : 011333

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on

this 28<sup>th</sup> day of October, 2003.

Bea MacDonald  
Buchanan Ingersoll, P.C.

**ELECTION AND AMENDMENT**

Pittsburgh, Pennsylvania 15219

October 28, 2003

Commissioner for Patents  
Post Office Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to Office Action dated September 30, 2003, please amend this application as set forth hereinafter.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begins on page 7 of this paper.